

APS-U Forum Update Dean R. Haeffner **APS-U Forum** March 23, 2016



Beamline Selection Process

- Call for White Papers for possible beamlines for inclusion in the APS-U Project
 - Deadline Jan. 25, 2016
 - 36 received
- Review of White Papers
 - APS-U Beamline Review Committee (Feb. 8 & 9, 2016)
 - Followed by APS/APS-U Management Review/Feedback
 - Discussion with APS Scientific Advisory Comittee (SAC) (Mar. 9 & 10, 2016)
 - Active discussion, but basically in agreement with presented plan
 - Final APS/APS-U Management discussions
- Call for Full APS-U Beamline Proposals from the approved White Papers
 - Results of White Paper process and feedback are being sent out this morning

Beamline Selection Process (cont.)

User Meeting Workshop

- Presentations & discussion on each proposal
- May 10, 2016 (Tuesday)
- Approximately 30 minutes each
- Review of Full APS-U Beamline Proposals
 - Deadline June 6, 2016
 - APS-U Beamline Review Committee (June 22 24, 2016)
 - Short presentations of each proposal to committee
 - APS/APS-U Management Prioritization/Selection
 - Presentation of Prioritization/Selection to the APS SAC for comment
 - Finalization of the Prioritization/Selection by APS/APS-U Management
 - Announcement tentatively July 18, 2016
- Selected Proposals developed to DOE Conceptual Design level

Guidelines for Full APS-U Beamline Proposals

30 pages max

- Brief Science Case (~10 pages)
- Explicit explanation of use of APS-U characteristics (1 5 pages)
 - Should include comparison to similar facilities and evaluate "world class/world leading" status
- Beamline description (10 15 page)
 - General layout
 - General discussion of optics
 - List of major components
 - No ray tracing/costing
- R&D needs, if any (2 pages)

APS-U will provide engineering, optics, ID calculation support

Community/Stakeholder discussion (2 pages)

Details for proposals will be sent to proposers in the next few days



Beamline Enhancement Data Gathering & Meetings

- Gather self-evaluation information from existing beamlines
 - Requests to CATs and XSD beamlines in early December
 - Beamline Fact Sheet
 - Beamline Enhancement Questionnaire
- Series of meetings with the staff of every beamline
 - Dean Haeffner, Mohan Ramanathan, Gary Navrotski
 - + XSD management for XSD beamlines
 - All beamlines covered 33 total meetings
 - Generally, 60 to 90 minutes
- Main Topics
 - Explanation of Beamline Enhancement process
 - Discussion Tier 1/Tier 2 philosophy, identification of possible items
 - Current understanding of APS-U effects on timing, beamline realignment, stability, etc.
 - Extensive discussion of insertion devices and/or bending magnet sources
 - Revolvers, superconducting undulators, horizontal devices, special polarization devices

Timeline/Process

- Oct.: Initiate a beamline technical evaluation and needs process
 - "Beamline Enhancements"
 - Data will provide a basis for a bottom up cost determination
- Feb. 1: Deadline for individual beamline self assessments
 - Self-assessment scope includes optics, stability, and source
 - Items fall into two types
 - Tier 1: Minor upgrades that are essential in order to be able to utilize beam from the APS-U "Do no harm"
 - Tier 2: Further upgrades that are desirable to be able to make the most out of the APS-U "Bang for the buck"
- Jan. Mar.: Meetings with beamline staff
- Feb. Apr. : APS-U/APS evaluation of self-assessments
 - Harass (gently?) delinquent beamlines to get data sheets, questionnaires
 - Iterate with beamline staff
 - Assemble prioritized Tier 1 and Tier 2 minor upgrade lists
- May July: Assemble conceptual design and basis of estimate beamline-by-beamline
- July 26-28 DOE Status Review

General Observation - Mirrors

Most beamlines are worrying about their mirrors

- APS-U increased coherence has everyone thinking about their old mirror slope error and roughness values
- 50% of Beamline Enhancement
 Questionnaires request new or refurbished mirrors
- 30X improvement in X-ray mirrors over the last 15 years is motivating







Mirror Performance for Coherence Preservation

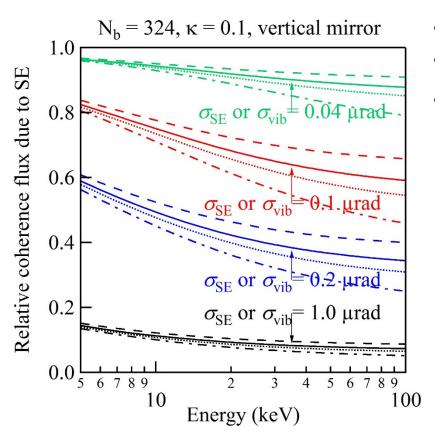


Figure courtesy of Xianbo Shi

$$\epsilon_0 = 32 \text{ pm}$$
 $\epsilon_0 = 50 \text{ pm}$
 $\epsilon_0 = 67 \text{ pm}$
 $\epsilon_0 = 100 \text{ pm}$

Typical mirrors originally installed at the APS had slope errors of 3 or 5 µrad

More recently (< 10 years) typically $1 - 3 \mu rad$

Many of these are still in use and some have degraded over time

Recently JTEC delivered mirror with 0.04 µrad slope error



General Observation

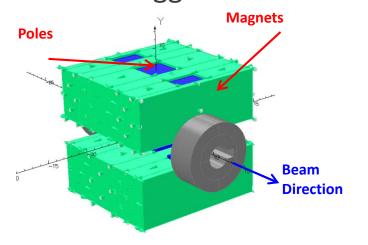
Larger variety of IDs = new power loads What is the effect on white beam components?

- Systematic FEA analysis of individual mechanical:
 - White beam windows
 - White beam slits
 - Power limiting apertures / Beam defining apertures
 - White beam filters
 - White beam stops
 - Power limiting choppers
- Systematic FEA analysis of individual optical:
 - White beam mirrors
 - Monochromators



General Observation - 3 Pole Wiggler BM Lines 3PW BM beamlines need white beam component mods

 Bending Magnet lines selecting a 3PW source for hard X-rays will need new 1st heat load optics. 3 Pole Wiggler BM Source



> 3X more power

Magnet	Field (T)	E _c (keV)	Ave Power (W/mradH)	Peak Power Density (W/mm²)
APS BM	0.599	19.519	87	1.24
APS-U 3PW	1.075	25.754	279	3.96

Front Ends Scope at CD-1

- Install 20 new High Heat Load front ends
- Modify 5 existing high heat load (HHL) front ends
- Install 3 new Canted Undulator front ends
- Modify 7 existing canted undulator (CU) fronts ends
- Modify and reuse the 23 existing bending magnet (BM) front ends

Front Ends Scope After Beamline Discussions

- Install 10 new High Heat Load front ends
- Modify 5 existing high heat load (HHL) front ends
- Install 7 new Canted Undulator front ends
- Modify 7 existing canted undulator (CU) fronts ends
- Additional 6 new CU in place of HHL front ends (5 CATs for future upgrades only CUFE and no straight section modifications)
- Modify and reuse the 23 existing bending magnet (BM) front ends



Insertion Devices

Device	At CD1	Requested	Comments
Planar	39	21	
Revolver	8	18	2 out of 3 heads populated.
SCU	3 + (2)	6 + (2)	2 locations – 2 devices each in one cryostat (2 devices one each for GSECCARS and HPCAT)
APPLE	4	4	
HGVPU		4	In tandem 2 In canted 2 ?
EMVPU	1 + (1)	1 + (1)	Find a new location
UPSCU		2	2 devices in one cryostat
3PW	23	8	Maybe 2 more for a max of 10

Device count in () is existing and may need minor modifications

Upcoming Optics Presentations of Interest

- Luca Peverini and James McVea, Thales/Sesso
 - Staying ~ 1.5 days
 - Arrive Monday March 14 morning and leave Tuesday March 15 afternoon
 - Talk Monday, March 14 at 2:00 pm 401-A1100
- Akihiko Ueda, JTEC
 - Staying approx. 3 days
 - Arrives Monday March 28 departs Wed. March 30
 - Talk Tuesday, March 29 at 2 pm 401-A1100
- Ray Barrett, ESRF
 - Staying one 1 week
 - Monday April 4- Friday April 8th
 - Talk Monday, April 4th at 2:00 pm 401-A1100
- Tom Tonnessen, Insync
 - Staying ~1 day
 - Arrives Wed. April 6th morning, departs 5:00 pm same day
 - Talk Wednesday, April 6 at 1:30 pm 401-A1100

Other Upcoming Events

- Series of APS-U Technical Review March to May
- IPAC16 (Busan, Korea) May 8-13, 2016
- APS/CNM Users Meeting APS-U Workshop May 10, 2016
- Full Proposal Review Committee Meeting June 22-24, 2016
- DOE OPA Review July 26-28, 2016
- Denver X-ray Conference August 1-5, 2016 (Rosemont, IL)
- MS&T16 (Salt Lake City) October 23-27, 2016
 - Symposium on Applications of Low Emittance Synchrotron X-ray Sources to Mesoscale Materials Studies (R. M. Suter & D. R. Haeffner, organizers)
 - Deadline March 31, 2016



Questions?

Thanks to Gary and Mohan for slides.

